



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 5653
Minjuan ZHANG et al. : Docket No. 2001-0712A
Serial No. 09/874,066 : Group Art Unit 1762
Filed June 6, 2001 : Examiner Timothy Howard MEEKS

METHOD AND SYSTEM FOR FORMING
COPPER THIN FILM

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RESPONSE TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents,
Washington, D.C. 20231

Sir:

In response to the Restriction Requirement of February 12, 2003, Applicants hereby elect the invention of Group I, claims 1-8, drawn to a method, without traverse, for further prosecution. In view of this election, a full examination on the merits of the present application is respectfully requested.

Respectfully submitted,

Minjuan ZHANG et al.

By: _____

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March 11, 2003

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